**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor Application of: Chentsau Ying et al.

§ Group Art Unit: 1765

Serial No.: 09/991,166

§ Examiner: L. Vinh

Filed: November 16, 2001

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Title: METHOD OF REDUCING PARTICULATES  
IN A PLASMA ETCH CHAMBER  
DURING A METAL ETCH PROCESS

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Attorney Docket No.:  
AM-5630.P1

Date: March 18, 2004

**PETITION FOR EXTENSION OF TIME**Hon. Commissioner for Patents  
P.O. Box 1450  
Arlington, Virginia 22313-1450

Sir:

1. This is a petition for a two-month extension of the time to file a response to the Office Action mailed November 5, 2003 in the subject patent application. The due date for the response was February 5, 2004, and the present two month extension of time will provide for a response through April 5, 2004.

**CERTIFICATE OF MAILING UNDER 37 CFR § 1.10**

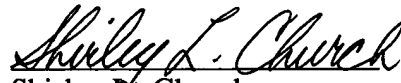
I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. ER534273792US in an envelope addressed to the: Mail Stop Amendment (With Fee), Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: March 18, 2004
  
 Shirley L. Church, Reg. No. 31,858

2.	Extension:	<u>Length of Extension</u>	<u>Fee Under 37 CFR § 1.17</u>
		<u>    </u> One-Month	\$110.00
		<u>  X  </u> Two-Month	\$420.00
		<u>    </u> Three-Month	\$950.00
		<u>    </u> Four-Month	\$1,480.00

3. The accompanying transmittal letter shows this fee of \$ 420.00 for the two-month extension of time.

Respectfully Submitted,

  
Shirley L. Church  
Registration No. 31,858  
Attorney for Applicants  
(650) 473-9700

Correspondence Address:  
Patent Counsel  
Applied Materials, Inc.  
P.O. Box 450A  
Santa Clara, California 95052